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Attorney's Docket No.: 042390P6958

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )

Anne E. Miller et al. )

U.S. Serial No: 09/461,158 )

Filed: December 14, 1999 )

For: HIGH PH SLURRY FOR )  
CHEMICAL MECHANICAL )  
POLISHING OF COPPER )

Examiner: Brown, C.

Art Unit: 1765

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Assistant Commissioner for Patents  
and Trademarks  
Washington, D.C. 20231

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed May 9, 2001. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on November 8, 2001  
Date of Deposit

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